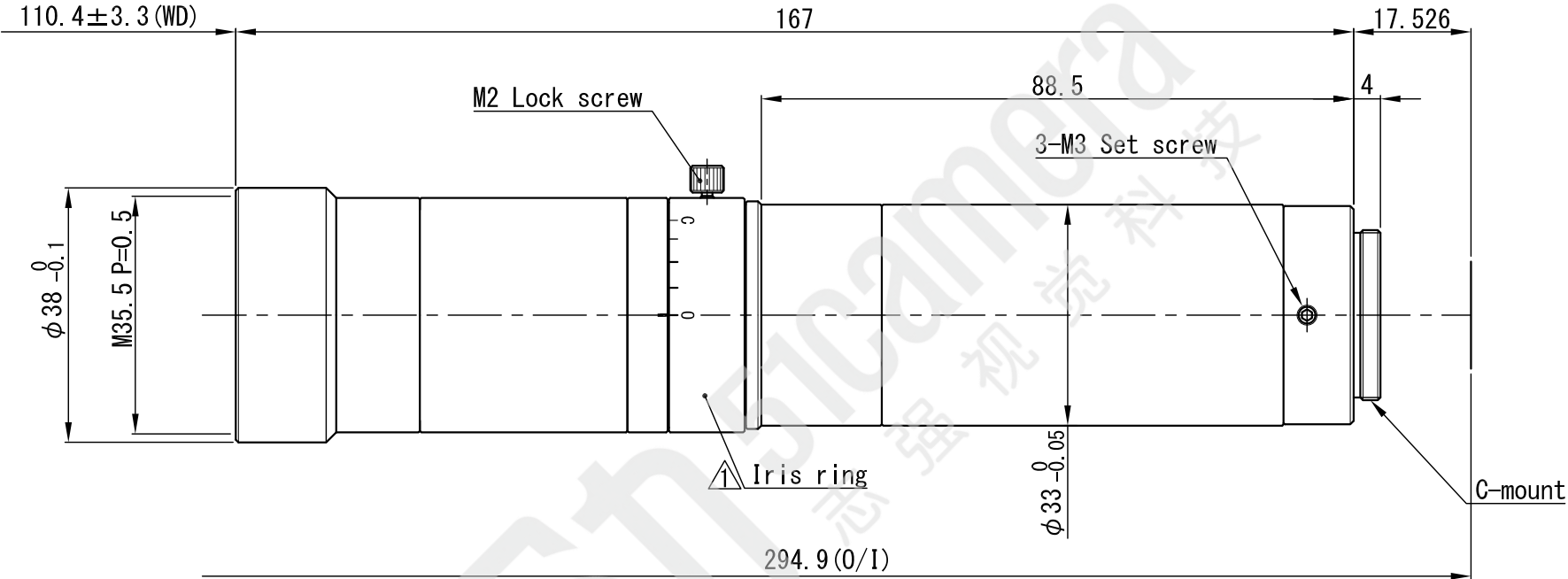




△×				APPROVED	CHECKED	MATERIAL 材料	—	CHAMFER 一般面取	—	QUANTITY 个数
△×				T. A.	T. A.	TREATMENT 处理	—	FINISHING 仕上	—	—
△×						TREATMENT CONTACT 处理接点	—	DECENTRATION 偏芯	—	
△×				DESIGNED	DRAWN	OVER 250 UP TO 1000	±0.3	±0.5	±1.0	±0.2
△×						OVER 63 UP TO 250	±0.2	±0.3	±0.6	±0.15
△×						OVER 16 UP TO 63	±0.1	±0.2	±0.4	±0.1
△×						OVER 0 UP TO 16	±0.05	±0.1	±0.2	±0.1
△×	Iris ring表記追加	19.03.03	T.F.	T. A.	T. T.	TOLERANCES	A	B	C	S
NO.×	REVISION 訂正事項	DATE	NAME			UNIT (mm)	SCALE	ANGLE 角度	METHOD 図法	REMARK 適用 (機種名)
						—	1 / 1	—	NAME	V S - T H V 2 - 1 1 0 / S
						DATE	15.03.17	DRAW NO.		D R A W I N G / 外 観 図
										0 D 0 E 0 8 3 1 A 2